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AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 2827
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q67536

Masamoto TAGO

Appln. No.: 09/998,243

Group Art Unit: 2827

Confirmation No.: 6291

Examiner: Lourdes C. Cruz

Filed: December 03, 2001

For: COMPACT SEMICONDUCTOR DEVICE CAPABLE OF MOUNTING A PLURALITY
OF SEMICONDUCTOR CHIPS WITH HIGH DENSITY AND METHOD OF
MANUFACTURING THE SAME

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 19, 2004, please amend the above-identified application as follows on the accompanying pages.